

10/26/2018

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Date/Time : 26/10/2018 12:10:50

Agent Number:

To,
ALVA'S EDUCATION FOUNDATIONALVA'S INSTITUTE OF ENGINEERING AND TECHNOLOGY SHOBHAVANA CAMPUS, MIJAR, MOODBIDRI,
DAKSHINA KANNADA - 574 225, KARNATAKA, INDIA. rpinto1942@gmail.com

Sr. No.	CBR No.	Reference Number / Application Type	Application Number	Title/Remarks	Amount Paid
1	30510	ORDINARY APPLICATION	201841040380	ENHANCEMENT OF MICRO DIRECT METHANOL FUEL CELL (μ -DMFC) PERFORMANCE USING MICRO CHANNELS FABRICATED	8800
2		E-101/25317/2018-CHE	201841040380	Correspondence	0
3		E-2/3245/2018-CHE	201841040380	Form2	0
4		E-3/28983/2018-CHE	201841040380	Form3	0
5		E-5/1769/2018-CHE	201841040380	Form5	0
Total :					8800

Received a sum of Rs. 8800 (Rupees Eight Thousand Eight Hundred only) through

Payment Mode	Bank Name	Cheque/Draft Number	Cheque/Draft Date	Amount in Rs
Cash	---	---	---	8800

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Application Details

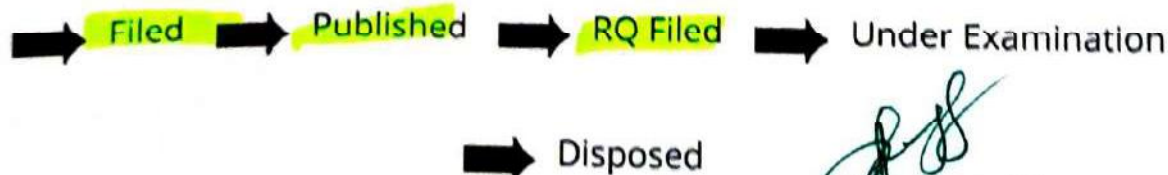
APPLICATION NUMBER	201841040380
APPLICATION TYPE	ORDINARY APPLICATION
DATE OF FILING	26/10/2018
APPLICANT NAME	ALVA'S EDUCATION FOUNDATION
TITLE OF INVENTION	ENHANCEMENT OF MICRO DIRECT METHANOL FUEL CELL (μ -DMFC) PERFORMANCE USING MICRO CHANNELS FABRICATED FROM <100> SILICON WAFER ORIENTATION AND P(VDF-TrFE) COATED NAFION MEMBRANE AS PROTON EXCHANGE MEMBRANE
FIELD OF INVENTION	ELECTRICAL
E-MAIL (As Per Record)	
ADDITIONAL-EMAIL (As Per Record)	rpinto1942@gmail.com
E-MAIL (UPDATED Online)	
PRIORITY DATE	
REQUEST FOR EXAMINATION DATE	25/08/2021
PUBLICATION DATE (U/S 11A)	14/12/2018

Application Status

APPLICATION STATUS

Application Awaiting Examination

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